Docket No.: 6317P013 FW



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

the Application of:

MEIR ALONI, ET AL.

Application No.: 10/661,719

Filed: September 11, 2003

For: Raster Frame Beam System For Electron

Beam Lithography

Art Group:

Examiner: Not Yet Assigned

INFORMATION DISCLOSURE STATEMENT UNDER 37 C.F.R. §1.97

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

In accordance with the duty of disclosure, enclosed is a copy of IDS Citation Form PTO/SB/08 or PTO-1449, together with copies of the documents cited on that form, except for copies not required to be submitted (e.g., copies of U.S. patents and U.S. published patent applications need not be enclosed for applications filed after June 30, 2003). This IDS and IDS Citation Form are being submitted. It is respectfully requested that the cited references be considered and that the enclosed copy of PTO/SB/08 be initialed by the Examiner to indicate such consideration and a copy thereof returned to applicant(s).

The references were cited in a Search Report dated July 8, 2004 (copy enclosed herewith) in a counterpart PCT application.

The submission of this Information Disclosure Statement is not to be construed as a representation that a search has been made in the subject application and is not to be construed as an admission that the information cited in this statement is material to patentability.

Respectfully submitted

Applied Materials, inc

Date: September 08, 2004

Tarek N. Falimi, Reg. No. 41,402

Patent Counsel P.O. Box 450A Santa Clara, CA 95052 Telephone: (408) 947-8200

I hereby certify that this correspondence is being deposited with the United States Postal Service on the date shown below with sufficient postage as first class mail in an envelope addressed to: Box: IDS, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(use as many sheets as necessary)

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	Application Number	10/661,719	
	Filing Date	September 11, 2003	
	First Named Inventor	Meir Aloni	
	Art Unit		
_	Examiner Name	Not Yet Assigned	
	Attorney Docket Number	6317P013	

U.S. PATENT DOCUMENTS					
Examiner Initials*	Cite No.1	Document Number Number - Kind Code² (if known)	Publication Date or Issue Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
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Initials*	No.1	Country Code³ - Number⁴ - Kind Code⁵ (if known)	Publication Date MM-DD-YYYY	Name of Patentee or Applicant of Cited Document	Where Relevant Passages or Relevant Figures Appear	T'
		WO 02/13226	02-14-2002	Allen, Paul, C.		
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

Sheet 2 **of** 2

Complete if Known			
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First Named Inventor Meir Aloni			
Art Unit			
Examiner Name	Not Yet Assigned		
Attorney Docket Number	6317P013		

	NON PATENT LITERATURE DOCUMENTS				
Examiner Initials*	Cite No.1	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T²		
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		"International Search Report", International Searching Authority, PCT/ US 03/34785, (7/08/2004)			
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